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[10191/4116]
REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP ART UNIT 2818

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : LAERMER et al.
Serial No. : 10/524,610
Filed : August 11, 2005
For : LAYER SYSTEM HAVING A SILICON LAYER
AND A PASSIVATION LAYER, METHOD FOR
CREATING A PASSIVATION LAYER ON A
SILICON LAYER AND ITS USE

Group Art Unit : 2818

Examiner : HO, Hoang Quan Tran
Confirmation No. : 9981

Mail Stop AF
Commissioner for Patents
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Date: September 5, 2007

Signature: Chih Li

TRANSMITTAL

SIR:

Enclosed herewith for filing in the above-identified patent application is a Reply
Under 37 C.F.R. § 1.116.

While no fee is believed due in connection with this paper, the Commissioner is
hereby authorized to charge payment of any additional fees associated with this
communication or credit any overpayment to the deposit account of **Kenyon & Kenyon
LLP**, deposit account number **11-0600**.

Respectfully Submitted,
KENYON & KENYON LLP

Dated: September 5, 2007

By: Gerard A. Messina

(Reg. No 35,952) *RV*

One Broadway
New York, NY 10004
(212) 425-7200

CUSTOMER NO. 26646

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S I R:

This paper is filed in response to the Final Office Action dated June 15, 2007 in connection with the above-captioned application.

Remarks begin on page 2 of this paper.